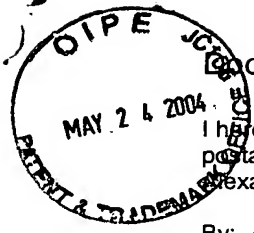


IFW



Docket No.: AR-R14

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By: 

Date: May 21, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No.	:	10/752,627	Confirmation No: 5973
Applicant	:	Anton Rodi	
Filed	:	January 7, 2004	
Title	:	Measuring Device to Record Values, in Particular Angles or Linear Segments	
Art Unit	:	2858	
Examiner	:	to be assigned	
Docket No.	:	AR-R14	
Customer No.	:	24131	

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner for Patents

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are submitted herewith:

United States Patent No. 5,414,516 (Morishita et al.), dated May 9, 1995, and corresponding German Published Non-Prosecuted Patent Application DE 44 19 050 A1, dated December 8, 1994;

United States Patent No. 5,485,407 (Ishimoto et al.), dated January 16, 1996;

United States Patent No. 5,943,639 (Tanaka et al.), dated August 24, 1999;

United States Patent Application Publication US 2002/0171418 A1 (Hinz et al.), dated November 21, 2002, and corresponding German Published Non-Prosecuted Patent Application DE 101 13 871 A1, dated September 26, 2002;

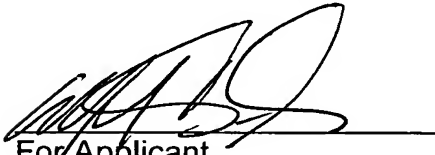
European Patent Application EP 0 394 942 A2 (Ishii et al.), dated October 31, 1990;

Tietze/Schenk: "Halbleitertechnik" [semiconductor technology], *Springer Verlag, Berlin*, 12th ed., 2002, chapter 11, pp. 751-792, chapter 17, pp. 966-977, chapter 18, pp. 984-986, 899-1011, chapter 20, pp. 1069-1074, and chapter 21, pp. 1134-1138;

European Search Report dated March 12, 2004.

If no translation of pertinent portions of any foreign language patents or publications mentioned above is included with the aforementioned copies of those applications, patents and/or publications, it is because no existing translation is readily available to the applicant. As per the Notice in 1273 OG 55 (August 5, 2003) no copies of any above-mentioned U.S. patents and U.S. patent application publications are submitted for any application filed after June 30, 2003.

Respectfully submitted,



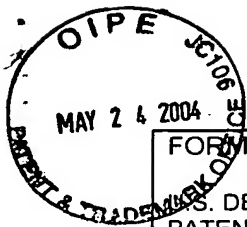
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/bmb



FORM PTO-1449 (SUBSTITUTE)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEINFORMATION DISCLOSURE
STATEMENT BY APPLICANT
(37 CFR 1.98(b))

Attorney Docket No.:

AR-R14

Applic. No.

10/752,627

Applicant

Anton Rodi

Filing Date

January 7, 2004

Group Art Unit

2858

U.S. PATENT DOCUMENTS

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A	5,414,516	05/09/95	Morishita et al.			
	B	5,485,407	01/16/96	Ishimoto et al.			
	C	5,943,639	8/24/99	Tanaka et al.			
	D	2002/0171418 A1	11/21/02	Hinz et al.			
	E						
	F						
	G						
	H						
	I						

FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES NO
	J	44 19 050 A1	12/08/94	Germany			
	K	101 13 871 A1	09/26/02	Germany			
	L	0 394 942 A2	10/31/90	Europe			
	M						
	N						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	O	Tietze/Schenk: "Halbleitertechnik" [semiconductor technology], <i>Springer Verlag, Berlin, 12th ed., 2002, chapter 11, pp. 751-792, chapter 17, pp. 966-977, chapter 18, pp. 984-986, 899-1011, chapter 20, pp. 1069-1074, and chapter 21, pp. 1134-1138</i>
	P	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.